



PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of

Gene LEE et al.

Appln. No.: 10/039,333

Group Art Unit: 1765

Filed: November 9, 2001

Examiner: B. Tran

Title: Method for Etching Tungsten
Using NF₃ and Cl₂

**PETITION FOR EXTENSION OF TIME
UNDER 37 C.F.R. § 1.136**

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Dear Sir:

Applicant hereby petitions for a three (3) month extension of time extending the period for reply to the Office Action mailed May 8, 2003 from August 8, 2003 to November 10, 2003 (November 8, 2003 falling on a Saturday). The Director of the U.S. Patent & Trademark Office is hereby authorized to charge the extension of time fee of \$970.00 to Deposit Account No. 18-1579.

The Director is also authorized to charge any fee deficiency, or credit any overpayment, to Deposit Account No. 18-1579.

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Respectfully submitted,

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